Methanesulfonic acid (MSA) and SO₃ formation from the addition channel of atmospheric dimethyl sulfide oxidation

Torsten Berndt

Co	ontents	
1.	Experimental approach and product analysis	2
2.	Kinetic analysis	3
3.	Reaction mechanism	4
4.	Additional figures	5
5.	References	8

1. Experimental approach and product analysis

The experiments were carried out in a laminar flow tube (LFT), operating at 1 bar of air at a temperature of 295 ± 0.5 K and a relative humidity of < 0.1 %. A humidity sensor (Hygrosense HYTE) continuously controlled the relative humidity of the reaction gas. The total flow was set at 30 L min⁻¹ (STP) resulting in a reaction time of 32 s, as experimentally determined using a "chemical clock". More detailed information on the experimental set-up is given elsewhwere.^{1,2}

Photolysis of isopropyl nitrite (IPN) by 24 36 W BLB lamps, emitting in the range 350 - 400 nm, was chosen for OH radical production. IPN photolysis forms i-C₃H₇O radicals and NO followed by the rapid reaction of i-C₃H₇O radicals with O₂ generating HO₂ radicals. Finally, the OH radial formation proceeds via the reaction NO + HO₂ \rightarrow OH + NO₂.³

For dosing dimethyl sulfoxide (CH₃S(O)CH₃), a vial containing this substance was directly connected to the main air stream just before entering the LFT. Diffusion of CH₃S(O)CH₃ from the vial was sufficient to get the desired CH₃S(O)CH₃ concentration in the reaction gas. The concentration was continuously controlled at the outflow of the flow system by means of a proton transfer reaction mass spectrometer (Ionicon, PTR-MS 500) measuring the calibrated (CH₃S(O)CH₃)H⁺ signal.

The initial CH₃S(O)CH₃ concentration of 4.2×10^{10} molecules cm⁻³, significantly higher than atmospheric level, allowed to follow product formation from secondary OH chemistry under the chosen reaction conditions, i.e., the products arising from the OH + CH₃S(O)OH reaction. The CH₃S(O)OH conversion was below ~(2 - 3) × 10⁸ molecules cm⁻³, that keeps the concentration of reactive intermediates low enough, i.e., below ~10⁸ and mostly below 10⁷ molecules cm⁻³. Thus, unwanted bimolecular steps, such as CH₃SO₂OO + RO₂ (path 9 in Scheme 1) or any CH₃SO₃ reactions with peroxy species etc., were unimportant for the material balance even for bimolecular rate coefficients being close to the collision limit. This ensured the simplified data analysis as carried out. Relatively high concentrations of NO, higher than over the oceans, were used in order to elevate the CH₃SO₃ formation via path **8**. Consequently, the product concentrations of SO₃ and MSA were higher compared with low-NO conditions. The approach of determination of the temperature dependence of k₁₁ is not affected by enhanced SO₃ concentrations using MSA formation via path **12** as the reference (assuming almost constant H-donor concentrations within a measurement series and an almost temperature-independent rate coefficient k₁₂).

All gas flows were set by means of calibrated gas flow controllers (MKS 1259/1179). The organic reactants and gases had the following purity: dimethyl sulfoxide (> 99.9 %, Aldrich), NO (498 \pm 10 ppmV NO (99.5 %) in N₂ (99.999 %), Air Liquide) and NO₂ (≥ 99.5 %, Aldrich). Needed gas mixtures were prepared by means of a gas mixing unit using He as the dilution gas. Purified air was taken from a commercial PSA (Pressure Swing Adsorption) unit with further purification by a series of absorber units filled with hopcalite (CuMnO_x catalyst), activated charcoal and different 4 Å and 10 Å molecular sieves.

Product formation was followed by means of a CI-APi-TOF (chemical ionization – atmospheric pressure interface – time-of-flight) mass spectrometer (Tofwerk AG, Airmodus) with a resolving power > 3000 Th/Th sampling from the center flow of the LFT with a rate of 10 L min⁻¹ (STP). The ion-molecule reaction (IMR) took place at atmospheric pressure using a

Boulder-type inlet system.⁴ As the reagent ions served iodide (I⁻), bromide (Br⁻), and nitrate (NO₃⁻). Their precursors tert-butyl iodide, tert-butyl bromide and nitric acid, respectively, were added to a 35 L min⁻¹ (STP) sheath flow of high-purity nitrogen forming the respective reagent ions after ionization with an ²⁴¹Am source.

CH₃S(O)OH, H₂SO₃ and CH₃SO₂OONO₂ were detected as the corresponding iodide adducts, (analyte)I⁻, and SO₂ as (SO₂)Br⁻ adduct. MSA and SO₃ were measured by means of nitrate ionization following the CH₃SO₃⁻ and the (CH₃SO₃H)NO₃⁻ signals or the SO₄⁻ and the (SO₃)NO₃⁻ signals, respectively. Calibration factors needed for determination of product concentrations as well as their uncertainties were the same as described previously.⁵ In the case of CH₃SO₂OONO₂, only lower limit concentrations with an uncertainty of a factor of two can be stated. Diffusion controlled wall loss for all products was considered using in each case $k_{loss} = 0.018 \text{ s}^{-1}$, see explanation in Berndt et al.⁵.

2. Kinetic analysis

The rate law of CH₃SO₃ product formation, "CH₃SO₃-prod" meaning SO₃ and MSA, is given by:

$$\frac{d[CH_3SO_3 - prod.]}{dt} = k_8 [NO] \times [CH_3SO_2OO] \#(S1)$$

The rate law for CH₃SO₂OO reads as follows:

$$\frac{d[CH_3SO_2OO]}{dt} = k_5 [O_2] \times [CH_3SO_2] - k_{-5} [CH_3SO_2OO] - k_8 [NO] \times [CH_3SO_2OO] \# (S2)$$

Steady-state approximation and the relationship $k_8 [NO] \ll k_{-5}$ leads to:

$$\begin{bmatrix} CH_3 SO_2 OO \end{bmatrix}_{ss} = \frac{\kappa_5}{k_{-5}} \begin{bmatrix} O_2 \end{bmatrix} \times \begin{bmatrix} CH_3 SO_2 \end{bmatrix} \# (S3)$$

Inserting Eq.S3 into Eq.S1 results in Eq.S4:
$$\frac{d \begin{bmatrix} CH_3 SO_3 - prod. \end{bmatrix}}{dt} = \frac{k_8 \times k_5}{k_{-5}} \begin{bmatrix} NO \end{bmatrix} \times \begin{bmatrix} O_2 \end{bmatrix} \times \begin{bmatrix} CH_3 SO_2 \end{bmatrix} \# (S4)$$

The rate law of SO₂ formation is given by:

1.

$$\frac{d[SO_2]}{dt} = k_6 \, [CH_3 SO_2] \# (S5)$$

Eq.S4 and Eq.S5 result in Eq.S6 given that NO is not significantly consumed in the course of the reaction.

$$\frac{[CH_3SO_3 - prod.]}{[SO_2]} = \frac{[SO_3] + [MSA]}{[SO_2]} = \frac{k_8}{k_6} \frac{k_5}{k_{-5}} [O_2] \times [NO] \# (S6)$$

The measured ratio $([SO_3] + [MSA]) / [SO_2]$ as a function of NO allows a rough estimate of the equilibrium constant $K_5 = k_5 / k_{-5}$ within the proposed reaction scheme given in Scheme 1 as long as NO₂ reactions can be neglected. Rate coefficients k_6 and k_8 must be taken from the literature.

3. Reaction mechanism

This mechanism was used to calculate the HO_2 level and the HCHO production as well as the fraction of non-reacted CH_3SO_3 for the reaction time of 32 s. A comparison of measured $CH_3S(O)OH$ (MSIA) products with results from modeling confirmed the applicability of this mechanism, see Figure S3 in Berndt et al.⁵.

Reaction	Rate coefficient (cm ³ molecule ⁻¹ s ⁻¹ or s ⁻¹)
$IPN (+O_2) \rightarrow NO + HO_2 + acetone$	0.00039
$NO + HO_2 \rightarrow OH + NO_2$	8.9×10 ^{-12, 6}
$OH + HO_2 \rightarrow H_2O + O_2$	1.1×10 ^{-10, 6}
$HO_2 + HO_2 \rightarrow H_2O_2 + O_2$	1.65×10 ^{-12, 6}
$OH + NO \rightarrow HNO_2$	9.7×10 ^{-12, 6}
$OH + NO_2 \rightarrow HNO_3$	1.2×10 ^{-11, 6}
$OH + DMSO (+O_2) \rightarrow MSIA + CH_3O_2$	8.7×10 ^{-11, 7}
$CH_3O_2 + HO_2 \rightarrow ROOH + O_2$	5.7×10 ^{-12, 6}
$CH_3O_2 + NO (+O_2) \rightarrow 0.9 \times CH_2O + 0.9 \times HO_2 + 0.9 \times NO_2$	7.7×10 ^{-12, 6}
$OH + SO_2 (+O_2) \rightarrow SO_3 + HO_2$	8.9×10 ^{-13, 8}
$OH + MSIA (+O_2) \rightarrow 0.53 \times H_2SO_3 + 0.34 \times SO_2$	9.0×10 ^{-11, 7}
$+ 0.87 \times CH_3O_2 + 0.13 \times CH_3SO_3$	
$CH_3SO_3 (+O_2) \rightarrow SO_3 + CH_3O_2$	0.076 ²
$CH_3SO_3 + CH_2O \rightarrow MSA + CHO$	1.6×10 ^{-15, 9 #}
$OH \rightarrow wall$	0.053 §
$HO_2 \rightarrow wall$	0.045 §
$CH_3O_2 \rightarrow wall$	0.018 §
$MSIA \rightarrow wall$	0.018 §
$H_2SO_3 \rightarrow wall$	0.018 §
$CH_3SO_3 \rightarrow wall$	0.018 §
$SO_3 \rightarrow wall$	0.018 §

Table S1: Reaction scheme describing the processes in the LFT. Rate coefficients at 295 K were taken from literature or have been estimated.

[#] this value is probably highly uncertain [§] diffusion-limited rate coefficient calculated for the LFT

4. Additional figures



Fig.S1 Ratio of CH₃SO₃ products, SO₃ and MSA, and SO₂ as a function of NO concentration. The data were taken from the measurement series as depicted in Fig.1. Open circles represent the ratio of the measurement data. The amount of non-reacted CH₃SO₃, determined from modeling, is considered in the full circles. Only the first data points were taken for calculation of the slope $\Delta y / \Delta x = 5.2 \times 10^{-12}$ (open circle) and 1.25×10^{-11} cm³ molecule⁻¹ (full circle).



Fig.S2 Concentrations of HO_2 radicals and HCHO at the LFT outflow from modeling as well as the measured ratio [MSA] / [SO₃] as a function of NO concentration. The experimental data were taken from the measurement series as depicted in Fig.1.



Fig.S3 Formed SO₃ (2nd generation product) as a function of CH₃C(O)OH (1st generation product) for different NO levels from the reaction of OH radicals with CH₃S(O)CH₃. Increasing CH₃S(O)CH₃ conversion was achieved by rising IPN concentrations (rising OH radical concentrations) for constant CH₃S(O)CH₃ concentration of 4.2×10^{10} molecules cm⁻³.



Fig.S4 MSA concentrations (2^{nd} generation product) as a function of formed CH₃C(O)OH (1^{st} generation product) for different NO levels from the measurement series shown in Fig.S3.



Fig.S5 Formation of CH₃S(O)OH, H₂SO₃, SO₃ and MSA (2^{nd} generation products) from the OH + CH₃S(O)CH₃ reaction as a function of added NO₂, see also Fig.2. Error bars show the uncertainty derived from absolute calibrations. For H₂SO₃, the calibration factor of CH₃S(O)OH was assumed with an uncertainty of ± 50 %. Reactant concentrations are given in the caption of Fig.2.



Fig.S6 Product concentrations of $CH_3S(O)OH$, H_2SO_3 and the sum of SO_3 and MSA as a function of temperature from the measurement series shown in Fig.3.

5. References

- 1. T. Berndt, H. Herrmann, M. Sipila, M. Kulmala, J. Phys. Chem. A, 2016, 120, 10150-10159.
- 2. T. Berndt, E. H. Hoffmann, A. Tilgner, F. Stratmann, H. Herrmann, *Nat. Commun.*, **2023**, *14*, 4849.
- 3. J. D. Raff, B. J. Finlayson-Pitts, Environ. Sci. Technol., 2010, 44, 8150-8155.
- 4. F. L. Eisele, D. J. Tanner, J. Geophys. Res., 1991, 96, 9295-9308.
- 5. T. Berndt, E. H. Hoffmann, A. Tilgner, H. Herrmann, *Angew. Chem. Int. Ed.*, **2024**, *63*, e202405572.
- 6. R. Atkinson, D. L. Bauch, R. A. Cox, R. F. Hampson, Jr., J. A. Kerr, J. Troe, *J. Phys. Chem. Ref. Data*, **1992**, *21*, 1125-1568.
- 7. I. Barnes, J. Hjorth, N. Mihalopoulos, Chem. Rev. 2006, 106, 940-975.
- R. Atkinson, D. L. Baulch, R. A. Cox, J. N. Crowley, R. F. Hampson, R. G. Hynes, M. E. Jenkin, M. J. Rossi, J. Troe, *Atmos. Chem. Phys.* 2004, *4*, 1461-2004.
- 9. F. Yin, D. Grosjean, J. H. Seinfeld, J. Atmos. Chem., 1990, 11, 309-364.